

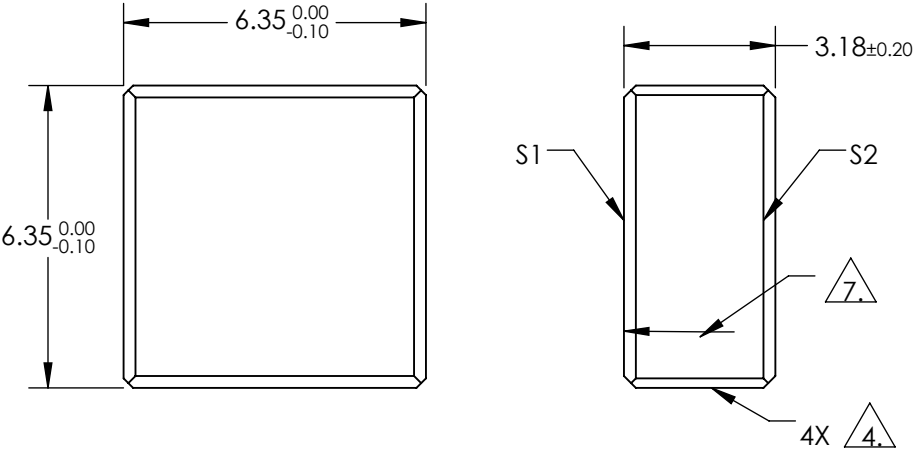
NOTES:

1. SUBSTRATE:  
Fused Silica
2. SURFACE S1 TO BE PARALLEL TO SURFACE S2 TO WITHIN <3 ARCMINS
3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.8% @ 266nm  
DAMAGE THRESHOLD,  
PULSED: 2 J/cm<sup>2</sup> @ 266nm, 20ns, 20Hz


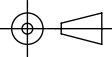
S2: NONE

4. FINE GROUND SURFACE
5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
7. ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1



**FOR INFORMATION ONLY:  
DO NOT MANUFACTURE  
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE  
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2	<div> Edmund Optics®</div>			
SHAPE	PLANO	PLANO				
SURFACE QUALITY	10-5	COMMERCIAL POLISH	<div>THIRD ANGLE PROJECTION</div> 	TITLE	6.35 x 6.35mm 266nm 0-45°, Nd:YAG Laser Line Mirror	
SURFACE FLATNESS	0.10 WAVE	N/A		DWG NO	39586	SHEET 1 OF 1
MIN CLEAR APERTURE	5.40 x 5.40	N/A				
MIN COATING APERTURE	5.40 x 5.40	N/A				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED				
			ALL DIMS IN	mm		